

<b>Notice of References Cited</b>	Application/Control No. 10/700,328		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Keath T. Chen		Art Unit 1762	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,372,754	12-1994	Ono, Hirofumi	261/142
*	C	US-4,685,331	08-1987	Renken et al.	73/204.15
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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